

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kwon et al.	)	I hereby certify that this paper is being
Serial No.: 10/609,505	)	deposited with the United States Postal Service, first class postage prepaid, addressed
Filed: June 30, 2003	)	to: MS RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
For: METHODS FOR MANUFACTURING CONTACT PLUGS FOR SEMICONDUCTOR DEVICES	) ) ) )	November 16, 2005
Group Art Unit: 1765	)	90-6
Examiner: Lan Vinh	)	James R. Zeller Reg. No. 28,491

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The patent listed on the enclosed Form PTO-1449 is identified pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. A copy of the patent is not enclosed.

By:

Entry and consideration of the submitted document is solicited.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

November 16, 2005

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## Sheet 1 of 1

Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 30205/39439	Serial No. 10/609,505
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INFORMATION DISCLOSURE STATEM		Applicant Kwon et al.	
INFORMATION DISCLOSURES	CLOSURE STATEMENT	Filing Date	Group
		June 30, 2003	1765

U.S. PATENT DOCUMENTS						
*Examiner Initials	Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate
	6,206,756	03-27-02	Chopra et al.	451	28	
				<u> </u>	ļ	
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	FOREIGN PATENT DOCUMENTS							
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
						İ	Yes	No
						-		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)				
	First Office Action received from Chinese Patent Office dated April 29, 2005.			

	Examiner	Date Considered		
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Ī	*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in			
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